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<b>To:</b>	Examiner C.Q. Nguyen Group Art Unit: 2811	<b>From:</b>	Leslie S. Szivos, Ph.D.
<b>Fax:</b>	703-872-9306	<b>Pages:</b>	16 including cover
<b>Phone:</b>		<b>Date:</b>	5/31/2005
<b>Re:</b>	Tze-chiang Chen, et al. U.S. Patent Appln. No. 10/700,085 Our Docket: YOR920030586US1 (17201)	<b>CC:</b>	

**XX Urgent**   ☐ **For Review**   ☐ **Please Comment**   ☐ **Please Reply**   ☐ **Please Recycle**

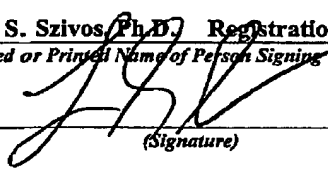
Dear Sir:

The following is attached hereto:


1. Amendment Transmittal in duplicate
2. Response under 37 CFR 1.111
3. Certificate of Facsimile

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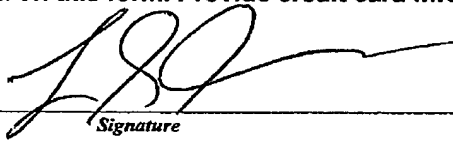
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<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b> Applicant(s): Tze-Chiang Chen, et al.			Docket No. <b>YOR920030586US1 (17201)</b>	
Application No. <b>10/700,085</b>	Filing Date <b>11/3/2003</b>	Examiner <b>C.Q. Nguyen</b>	Group Art Unit <b>2811</b>	
Invention: <b>METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES</b>				
<p>I hereby certify that this <u>                    <b>RESPONSE UNDER 37 CFR §1.111</b>                    </u> <i>(Identify type of correspondence)</i></p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>)</p> <p>on <u>May 31, 2005</u> <i>(Date)</i></p> <p style="text-align: center;"><u>Leslie S. Szivos/Ph.D. Registration No. 39,394</u> <i>(Typed or Printed Name of Person Signing Certificate)</i></p> <p style="text-align: center;"> <i>(Signature)</i></p> <p style="text-align: center;"><b>Note: Each paper must have its own certificate of mailing.</b></p>				

P18/REV02

<b>AMENDMENT TRANSMITTAL LETTER (Large Entity)</b>					<b>Docket No.</b> <b>YOR920030586US1 (17201)</b>	
<b>Applicant(s):</b>						
<b>Application No.</b> 10/700,085	<b>Filing Date</b> 11/3/2003	<b>Examiner</b> C.Q. Nguyen	<b>Customer No.</b> 23389	<b>Group Art Unit</b> 2811	<b>Confirmation No.</b> 2805	
<b>Invention: METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES</b>						
<b>COMMISSIONER FOR PATENTS:</b>						
Transmitted herewith is an amendment in the above-identified application.						
The fee has been calculated and is transmitted as shown below.						
<b>CLAIMS AS AMENDED</b>						
	<b>CLAIMS REMAINING AFTER AMENDMENT</b>	<b>HIGHEST # PREV. PAID FOR</b>	<b>NUMBER EXTRA CLAIMS PRESENT</b>	<b>RATE</b>	<b>ADDITIONAL FEE</b>	
<b>TOTAL CLAIMS</b>	36 -	68 =	0	x \$50.00	\$0.00	
<b>INDEP. CLAIMS</b>	3 -	6 =	0	x \$200.00	\$0.00	
<b>Multiple Dependent Claims (check if applicable)</b> <input type="checkbox"/>					\$0.00	
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT</b>					\$0.00	
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <input type="checkbox"/> Payment by credit card. Form PTO-2038. <b>WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.</b>						
 _____ <b>Signature</b>			<b>Dated: May 31, 2005</b>			
<b>Leslie S. Szivos, Ph.D.</b> <b>Reg. No. 39,394</b>			<div style="border: 1px solid black; padding: 5px;"><p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____</p><p style="text-align:center;">(Date)</p><p style="text-align:center;">_____ <i>Signature of Person Mailing Correspondence</i></p><p style="text-align:center;">_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></p></div>			
<b>CC:</b>						

P11LARGE/REV09

<b>AMENDMENT TRANSMITTAL LETTER (Large Entity)</b>					<b>Docket No.</b> <b>YOR920030586US1 (17201)</b>	
<b>Applicant(s):</b>						
<b>Application No.</b> 10/700,085	<b>Filing Date</b> 11/3/2003	<b>Examiner</b> C.Q. Nguyen	<b>Customer No.</b> 23389	<b>Group Art Unit</b> 2811	<b>Confirmation No.</b> 2805	
<b>Invention: METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES</b>						
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<b>TOTAL CLAIMS</b>	36 -	68 =	0	x \$50.00	\$0.00	
<b>INDEP. CLAIMS</b>	3 -	6 =	0	x \$200.00	\$0.00	
<b>Multiple Dependent Claims (check if applicable)</b> <input type="checkbox"/>					\$0.00	
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT</b>					\$0.00	
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <input type="checkbox"/> Payment by credit card. Form PTO-2038. <b>WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.</b>						
 _____ <i>Signature</i>			<b>Dated: May 31, 2005</b>			
<b>Leslie S. Szivos, Ph.D.</b> <b>Reg. No. 39,394</b>			<div style="border: 1px solid black; padding: 5px;"><p>_____ hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____</p><p style="text-align:center;">_____ (Date)</p><p style="text-align:center;">_____ <i>Signature of Person Mailing Correspondence</i></p><p style="text-align:center;">_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></p></div>			
<b>CC:</b>						

P11LARGE/REV09

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****Applicant(s):** Tze-chiang Chen, et al.**Examiner:** C.Q. Nguyen**Serial No:** 10/700,085**Art Unit:** 2811**Filed:** November 3, 2003**Docket:** YOR920030586US1 (17201)**Dated:** May 31, 2005**For:** METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND  
Ge-ON-INSULATOR (GOI) SUBSTRATES**Confirmation No.** 2805Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**RECEIVED  
CENTRAL FAX CENTER****MAY 31 2005****RESPONSE UNDER 37 C.F.R. § 1.111**

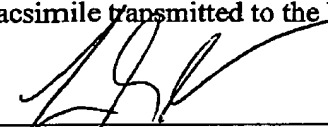
Sir:

In response to the Office Action dated February 28, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

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**CERTIFICATION OF FACSIMILE TRANSMISSION**

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**Dated:** May 31, 2005  
\_\_\_\_\_  
Leslie S. Szivos, Ph.D.